



Article Epitaxial Growth and Structural Characterizations of MnBi₂Te₄ Thin Films in Nanoscale

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Abstract: The intrinsic magnetic topological insulator MnBi₂Te₄ has attracted much attention due to its special magnetic and topological properties. To date, most reports have focused on bulk or flake samples. For material integration and device applications, the epitaxial growth of MnBi₂Te₄ film in nanoscale is more important but challenging. Here, we report the growth of self-regulated MnBi₂Te₄ films by the molecular beam epitaxy. By tuning the substrate temperature to the optimal temperature for the growth surface, the stoichiometry of MnBi₂Te₄ becomes sensitive to the Mn/Bi flux ratio. Excessive and deficient Mn resulted in the formation of a MnTe and Bi₂Te₃ phase, respectively. The magnetic measurement of the 7 SL MnBi₂Te₄ film probed by the superconducting quantum interference device (SQUID) shows that the antiferromagnetic order occurring at the Néel temperature 22 K is accompanied by an anomalous magnetic hysteresis loop along the *c*-axis. The band structure measured by angle-resolved photoemission spectroscopy (ARPES) at 80 K reveals a Dirac-like surface state, which indicates that MnBi₂Te₄ has topological insulator properties in the paramagnetic phase. Our work demonstrates the key growth parameters for the design and optimization of the synthesis of nanoscale MnBi₂Te₄ films, which are of great significance for fundamental research and device applications involving antiferromagnetic topological insulators.

Keywords: MnBi₂Te₄; topological insulators; antiferromagnetic order; molecular beam epitaxy

1. Introduction

Magnetic topological insulators (TIs) are an attractive platform because their finite magnetic moment provides mass to the massless Dirac fermions, thereby opening an energy gap in an otherwise gapless Dirac state, leading to several emerging topologically driven quantum states [1–3]. Two salient examples are the quantum anomalous Hall (QAH) insulator [4,5] and the axion insulator states [6–8]. These axion insulator states require an atypical magnetic profile; the magnetizations of the top and bottom surfaces of the TI must align oppositely [6–10]. Axion insulators have been observed so far only in atomically tailored TI heterostructures. A natural axion insulator was discovered in layered compound $MnBi_2Te_4$, in which the necessary magnetic profile was achieved through an intrinsic antiferromagnetic coupling of the adjacent atomic layers. Furthermore, upon applying a magnetic field to control the arrangement of the interlayer spins in $MnBi_2Te_4$, the states of QAH insulators and axion insulators become interchanged [11–20]. Axion insulators and Chern insulators have recently been realized in mechanically exfoliated



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Copyright: © 2021 by the authors. Licensee MDPI, Basel, Switzerland. This article is an open access article distributed under the terms and conditions of the Creative Commons Attribution (CC BY) license (https:// creativecommons.org/licenses/by/ 4.0/). MnBi₂Te₄ flakes [12,21–23], but such flakes are fragile and have small and irregular shapes, thus preventing the large-scale fabrication of devices that utilize the QAH effect. Moreover, the fabrication of MnBi₂Te₄ flakes requires heating to a high temperature, which readily causes high-density intrinsic defects. Such defects in MnBi₂Te₄ not only cause bulk metallic conductivity, preventing the measurement of the quantum transport of the surface states, but it might also affect magnetic and topological properties [24,25].

In these respects, the molecular beam epitaxy (MBE) method is potentially a promising technique for the synthesis of van der Waals (vdW) materials such as MnBi₂Te₄ because the deposition temperature is lower than for flakes grown in thermal equilibrium; the former can decrease the defect concentration [26,27]. Furthermore, the thin-film configuration can provide a suitable platform to realize various artificial MnBi₂Te₄ stacking structures, for example, heterostructures and hybrid systems with other materials such as ferromagnets [28–32]. Hence, the MBE growth of high-quality MnBi₂Te₄ films is essential for the practical development of devices specifically designed to exploit the remarkable properties of the QAH state and axion insulator state. To date, the MBE growth of MnBi₂Te₄ has been pursued by a few groups [31–38]. Despite great effort, the preparation of high-quality MnBi₂Te₄ thin films has become a major challenge in this developing field.

In this work, we report the synthesis of $MnBi_2Te_4$ films grown on sapphire substrates with the MBE method. We demonstrate that a self-regulated growth window at the optimal substrate temperature controlled with a Mn/Bi flux ratio emerged through the higher volatility of Te and yielded high-quality $MnBi_2Te_4$ films of a single phase. The MBE growth parameters and structural characterization of the $MnBi_2Te_4$ films were studied with X-ray diffraction (XRD) and Raman spectra. The magnetic properties of $MnBi_2Te_4$ thin films characterized with SQUID indicate that antiferromagnetic order occurring at Néel temperature 22 K was accompanied by an anomalous magnetic hysteresis loop along the *c*-axis. The band structure studied with angle-resolved photoemission spectra revealed a Dirac-like surface state. This work establishes a systematic approach to the epitaxial growth of high-quality $MnBi_2Te_4$ films for future device applications.

2. Experimental Section

The MnBi₂Te₄ samples were grown on *c*-plane Al₂O₃ substrates with the molecular beam epitaxy (AdNaNo Corp., model MBE-9, New Taipei, Taiwan) method in an ultrahigh vacuum (UHV) chamber equipped with reflection high-energy electron diffraction (RHEED) [39,40]. Highly pure Mn (99.99%), Bi (99.9999%) and Te (99.9999%) were coevaporated from Knudsen effusion cells. The cell temperature was adjusted precisely before growth to provide the required flux, which was calibrated with the beam flux monitor. Before loading Al₂O₃ substrates into the growth chamber, the Al₂O₃ substrates were ultrasonically cleaned in acetone, isopropyl alcohol and deionized water for 10 min, respectively, and then blown by pure N₂ to the surface before being loaded into the growth chamber. To remove possible contaminants on the surface, the Al_2O_3 substrates were heated to 1000 °C and kept for 1 h before the growth of the MnBi₂Te₄ films. During the growth, the Te flux was supplied in excess to overcome the high volatility and to decrease the formation of Te defects. The composition of the films was controlled by the Mn/Bi flux ratio. The flux ratio of Mn/Bi is calibrated with the beam flux monitor (BFM), which is an ion gauge that can measure the equivalent pressure of the molecular beam. To facilitate the epitaxial growth of MnBi₂Te₄, a Bi₂Te₃ buffer layer (1 quintuple layer, QL) was first grown on the Al₂O₃ substrate at a substrate temperature of 370 °C. The Bi₂Te₃ layer was further annealed to the desired growth temperatures under Te-rich conditions; the MnBi₂Te₄ films were then deposited on the buffer layers. The nominal growth rate of the Bi_2Te_3 and MnBi₂Te₄ films were QL/7 min and SL/4 min, respectively. The samples used for SQUID, angle-resolved photoemission spectra (ARPES) and a scanning tunneling microscope (STM) were covered in situ with amorphous Te capping layers (1~2 nm) in an MBE system to avoid surface oxidation. The crystalline condition of the grown thin film was monitored in situ with RHEED. X-ray diffraction (XRD), a high-resolution transmission electron microscope (HRTEM) and Raman spectra provided structural characterization. The Raman spectra were recorded on a micro-Raman spectrometer with an excitation wavelength of 532 nm. The elemental composition of the samples was calibrated with a transmission electron microscope energy-dispersive system (TEM-EDS) (see Supplementary Materials). The surface morphology was characterized with an atomic force microscope (AFM). The magnetic properties as a function of temperature from 5 to 300 K were measured with a SQUID magnetometer (Quantum Design MPMS SQUID VSM system). An external magnetic field was applied to the surface of the epitaxial layer in either an in-plane or outof-plane direction. The diamagnetic contribution of the Al₂O₃ substrate was determined from the slope of the magnetization M(H) recorded at large magnetic fields and at 300 K, well above the Néel temperature of MnBi₂Te₄; the derived substrate contribution was then subtracted from the raw data recorded at a lower temperature. The ARPES experiment was performed at beamline 21B1 of Taiwan Light Source in the National Synchrotron Radiation Research Center (NSRRC). Before the ARPES measurement, the Te-covered MnBi₂Te₄ film was annealed at 180 °C for about 1 h to remove the capping Te layer. ARPES were recorded in a UHV chamber equipped with a hemispherical analyzer (VG Scienta R4000, Uppsala, Sweden) [41]. All spectra were recorded at 80 K under base pressure 8.3×10^{-11} torr and at incident photon energy 24 eV. The angle resolution was about 0.2° ; the overall energy resolution was better than 12 meV.

3. Results and Discussion

3.1. Structural Characterizations

To understand the structural evolution of a $MnBi_2Te_4$ film as a function of the Mn/Biflux ratio (φ_r) and the growth temperature (T_G), we performed X-ray diffraction (XRD) studies on samples in two series. Figure 1a shows the θ -2 θ scans for which φ_r was tuned from 0.09 to 1; $T_{\rm G}$ was fixed at 410 °C. All MnBi₂Te₄ films were *c*-axis (0001)-oriented, which was confirmed with a series of signals that closely match the (003n) signals of bulk MnBi₂Te₄ [15,42]. Additional signals were observed at about $2\theta = 27^{\circ}$ and 55° , which are consistent with the formation of a MnTe phase [34]. The intensity of the MnTe phase gradually weakened as φ_r decreased from 1 to 0.1. When φ_r decreased to 0.09, the MnTe phase disappeared, leaving only the MnBi₂Te₄ phase. It should be noted that with further decreasing φ_r , the XRD spectrum shows diffraction patterns similar to those of Bi₂Te₃, except that the diffraction peaks are broader than those of Bi₂Te₃. This suggests that at a lower Mn/Bi ratio, Mn atoms mainly act as dopants without significantly changing the crystalline structure of Bi_2Te_3 . The trends are consistent with the previous reports [33]. Moreover, compared with the previous study [34], the quartz crystal microbalance (QCM) was used to calibrate the φ_{r} , which is different from the calibration by BFM in our study. The calibration with the QCM is to measure the frequency response of solid material deposited on the QCM. This φ_r is often linearly related to the ratio of solid materials deposited on the substrate. The calibration method we used is to measure the partial pressure of the molecular beam (Mn, Bi, Te) in the gas phase, and this partial pressure ratio is often not so linear with the ratio of the solid materials deposited on the substrate. This is because the reaction (e.g., sorption and desorption) of gas-phase materials on the substrate can be quite complicated. Therefore, the difference in φ_r between our work and the previous result is likely due to the different calibration methods adopted in the two systems. Figure 1b shows the XRD results for which $T_{\rm G}$ varied from 310 to 440 °C; the flux ratio was fixed at $\varphi_r = 0.09$. For films grown at temperatures 310~340 °C, the intensities of the resolved signals were too weak, but these signals were well distinguished from those of Bi₂Te₃. With $T_{\rm G}$ increased to 380~410 °C, these signals became well resolved; the intensities increased, which clearly showed the (003n) signals of MnBi₂Te₄ [15,34,36,42] with no impurity phase. However, when $T_{\rm G}$ increased to 440 °C, volatile Bi-Te was desorbed and additional MnTe signals emerged because of the higher growth temperature. The RHEED in situ showed clear strip patterns, indicating a high crystalline quality and a flat surface of the MnBi₂Te₄ films, as shown in Figure 1d. Raman spectra were used to investigate

how the change of φ_r affected the lattice vibration and the electron–phonon interaction in the MnBi₂Te₄ films, as shown in Figure 1c. The characteristic phonon modes A_{1g}^2 , E_g^2 and A_{1g} were identified in the region of a small wavenumber. The Raman spectra of MnBi₂Te₄ film have an appreciable blue shift relative to Bi₂Te₃, which is attributed to the stronger in-plane bond of Mn-Te [42]. As φ_r increased from 0.09 to 1, Raman spectra were observed to be red-shifted in these films. The decreasing wavenumber of the vibrational modes $(E_g^2$ and $A_{1g})$ is associated with an increase in Mn atoms until the formation of Mn interstitial clusters that might be located in the vdW gaps and connected to the Te atoms of the SL [43]. The optimal growth parameters of the MnBi₂Te₄ films occurred at approximately $\varphi_r = 0.09$ and $T_{\rm G}$ = 410 °C. For a thin film prepared under the optimized conditions, the HRTEM was applied to examine the film quality. Figure 1e shows the HRTEM image along the *c*-axis direction, clearly showing the characteristic septuple-layer (SL) structure of the vdW stacking in a MnBi₂Te₄ epitaxial film. The film thickness was identified as 7 SL. The atomic structure of each SL is visible in the enlarged image (Figure 1f). As the atomic number of Bi is much greater than that of Te and Mn, the Bi atomic column looks brightest, which is also shown in the inset with the superimposed structural model (see the illustration in Figure 1e). The stoichiometry of the film was estimated using the TEM-EDS as shown in Figure S1 and Table S1 (see Supplementary Materials), which showed that Mn:Bi:Te was 1:2.17:3.99, which is consistent with the chemical formula of compound MnBi₂Te₄. These results indicate that, for the epitaxial growth of stoichiometric crystalline MnBi₂Te₄ films, the growth temperature and the Mn/Bi flux ratio have narrow windows.



Figure 1. The structural characterizations of epitaxial MnBiTe films under varied growth conditions. The XRD diagrams for (**a**) $T_{\rm G}$ fixed at 410 °C with varied φ_r and (**b**) φ_r fixed at 0.09 under varied $T_{\rm G}$ (indicated on the right-hand axis). As indicated in the figure, the signals are marked as *: *c*-plane Al₂O₃ substrate. The dashed vertical arrows highlight the emergence of the MnTe phase. (**c**) Raman spectra of films for varied φ_r . The dotted lines represent raw data; the solid color lines are fits through the raw data. (**d**) RHEED patterns of films along directions [0110] and [2110], respectively. (**e**) TEM cross-sectional view of the film with $\varphi_r = 0.09$ and $T_{\rm G} = 410$ °C. (**f**) Enlarged TEM image and schematic structure of MnBi₂Te₄ are superimposed: blue-Bi, green-Mn, red-Te.

3.2. Surface Morphology

The surface morphology depended strongly on φ_r and T_G . Figure 2a shows the surface of a Bi₂Te₃ film as grown, indicating flat terraces. The surface was composed of characteristic triangular terraces and steps, reflecting the growth of the hexagonal crystal Bi₂Te₃ along (0001) [44,45]. The individual terraces were preferentially aligned with each other; an occasional rotation of 60° was observed, possibly due to the formation of twin boundaries [44]. For $\varphi_r = 0.09$ and $T_G = 310$ °C, the film surface showed misoriented domains with ambiguous shapes and bright islands, which indicated poor crystalline

quality (Figure 2b). The root mean square (rms) roughness was about 6.54 nm. Because $T_{\rm G}$ was too low, adatoms had insufficient energy to diffuse and to move to sites of least potential energy; they then formed a polycrystalline film. As $T_{\rm G}$ increased to 410 °C at $\varphi_r = 0.09$, the most noticeable feature was the large and flat undefined morphology, as shown in Figure 2c. A significant reduction in 3D bright structures was observed over a large-scale area; its rms roughness was 0.82 nm, which is much less than that of Figure 2b. The layering step is distinguishable on the enlarged surface shown in Figure 2e. The step height is ~1.4 nm (inset of Figure 2e), which is the same as the height of a single SL of MnBi₂Te₄ [25,46]. For $\varphi_r = 0.5$ and $T_{\rm G} = 410$ °C, the surface showed randomly oriented elongated structures, which might be due to the formation of a Mn-rich phase; its rms roughness was 3.85 nm. The STM result revealed that the hexagonal atomic structure on the surface is consistent with the imaging of the topmost Te layer [46,47]; the in-plane lattice parameter was 4.0 Å, as shown in Figure 2f. These structural features confirmed by the AFM and XRD reveal the high quality of the pure MnBi₂Te₄ films grown by the delicate MBE method.



Figure 2. The dependence of film morphology on T_G and φ_r from an AFM: (**a**) Bi₂Te₃ surface (3 µm × 3 µm). (**b**) $\varphi_r = 0.09$ and $T_G = 310 \degree \text{C}$ (3 µm × 3 µm); (**c**) $\varphi_r = 0.09$ and $T_G = 410 \degree \text{C}$ (3 µm × 3 µm); (**d**) $\varphi_r = 0.5$ and $T_G = 430 \degree \text{C}$ (3 µm × 3 µm); (**e**) Magnified AFM image of (**c**); the inset is a height profile along the blue solid line marked in (**e**), showing a step size of 1.4 nm. (**f**) Atom-resolved STM image of (**c**), showing Te-terminated hexagonal atomic structure (size: 6 nm × 6 nm, sample bias: 0.5 V, tunnel current: 0.2 nA).

3.3. Magnetic Properties

In the 2D limit, the odd SL of MnBi₂Te₄ exhibit QAH insulators and Chern insulators [14,22,48]. The 7 SL and 11SL MnBi₂Te₄ were used to measure the magnetic properties; these properties of a MnBi₂Te₄ film were inspected with a SQUID measurement. Figure 3a displays the field-cooled (FC) and zero-field-cooled (ZFC) curves of the 7 SL MnBi₂Te₄ film when the magnetic field (~1 T) was along the *c*-axis (H//c) and in-plane *ab* (H//ab), respectively. The overlapping FC and ZFC curves and λ -shaped feature with an inflection point indicated an A-type antiferromagnetic coupling along the *c*-axis. The Néel temperature (T_N) of the sample was about 22 K, consistent with previous work [15,17,42]. The FC and ZFC curves deviated from each other when the temperature was less than T_N , which implies the emergence of a net ferromagnetic moment. When the field was applied along plane *ab* (H//ab), the magnetic moment decreased to one-third, indicating that the MnBi₂Te₄ film had strong magnetic anisotropy. Figure 3b shows the field dependence in plane (H//ab)and out of plane (H//c) of magnetization curves of a 7 SL MnBi₂Te₄ sample. The M-H loop out of plane exhibits a non-linear ferromagnetic shape, whereas the *M*-*H* loop in plane is much flatter, indicating a perpendicular magnetic anisotropy with the easy magnetization axis along the *c*-axis [42,49]. For H//c, the *M*-*H* curve exhibits an anomalous magnetic hysteresis loop centered at the regime of a small magnetic field, indicating the spin-flip of individual layers and a ferromagnetic feature, which differs from the antiferromagnetic characteristics of MnBi₂Te₄ bulk and flakes [42,49,50]. In bulk and exfoliated flakes of MnBi₂Te₄, the *M*–*H* curves are nominally flat in the regime of a small magnetic field. The residual ferromagnetic response might originate from a possible substrate-induced effect, asymmetric upper and lower surfaces, or uncompensated layers [17,48]. Under magnetic field 3 T, the spin-flip transition occurred as indicated by red arrows in Figure 3b. Similar large-field magnetic behavior was observed in MnBi₂Te₄ flakes [42,48–50]. Figure 3c shows the field dependence out of plane of the magnetization curve of a 7 SL MnBi₂Te₄ sample in the temperature range from 10 K to 30 K. The anomalous magnetic hysteresis loop dwindled with increasing temperature and disappeared at 30 K, which indicates that a magnetic phase transition from an antiferromagnetic state to a paramagnetic state occurred with increasing temperature, consistent with the observation of M-T curves in Figure 3a. Figure 3d shows the field dependence out of plane of the magnetization curves of a 7 SL MnBi₂Te₄ sample for varied φ_r . Compared with the sample with $\varphi_r = 0.09$, for the sample with $\varphi_r = 1$, the magnetic hysteresis loop out of plane vanished because of the in-plane magnetic anisotropy of the MnTe phase [51]. To study the thickness-dependent magnetism, the magnetic properties of MnBi₂Te₄ with 7 SL and 11 SL thickness were observed. Figure 3e shows the ZFC and FC curves of 7 SL and 11 SL MnBi₂Te₄ films, with the magnetic field (~1 T) along the *c*-axis (H//c). It should be noted that the Néel temperature (T_N) of 11 SL MnBi₂Te₄ film slightly increases to 23 K compared to that of 7 SL. Figure 3f shows the out-of-plane *M*–*H* loop of 7 SL and 11 SL MnBi₂Te₄. The magnetic hysteresis loop centered at the regime of low magnetic fields is persistent in both samples. However, under high magnetic fields, the spin-flip transition of 11 SL is not obvious, which may be due to the tilt or disorder of the antiferromagnetic configuration as the thickness increases.

3.4. Band Structure

The electronic structure of 7 SL MnBi₂Te₄ with growth parameters $\varphi_r = 0.09$ and $T_{\rm G}$ = 410 °C was studied with ARPES, which were recorded at 80 K, to which the sample was paramagnetically ordered. Before the ARPES measurements, an XPS experiment after removing the Te capping layer was conducted to confirm the surface condition. Mn 3*p*, Te 4*d* and Bi 5*d* features could be observed clearly from the XPS spectrum, as shown in Figure 4a. Figure 4b,c displays the band-mapping results of a MnBi₂Te₄ sample along direction Γ -K and the second derivative of the photoemission intensity, respectively. A Dirac point of MnBi₂Te₄ was identified in the band gap and differed from the Dirac point buried in the valence band for Bi₂Te₃ [37,52]. The Fermi level was located above the Dirac point and crossed the bulk conduction band (BCB), indicating that the charge carriers were mainly *n*-type. The Fermi vector ~0.13 Å^{-1} can be identified from the momentum distribution curve (MDC). The surface carrier concentration estimated from the occupied area of the 2D FS area/the area of surface BZ without counting the spin degeneracy is around $\sim 1.34 \times 10^{13}$ cm⁻², which is higher than that of previous works. [37] This observation indicates that a surface Dirac cone existed in the MnBi₂Te₄ film in the paramagnetic state, which is consistent with previous ARPES studies [18,37]. In addition, the band-mapping result exhibits heavily *n*-doped behavior in this work. A possible reason might be attributed to a higher substrate growth temperature in our work, which could create more Te vacancies or antisite defects. [24,25]



Figure 3. The magnetic properties of a 7 SL MnBi₂Te₄ film. (**a**) The temperature dependence of the magnetic moment under ZFC and FC processes with magnetic fields out of plane (H//c) and in plane (H//ab), respectively. (**b**) The field dependence of the magnetization of a film measured at 10 K with magnetic fields out of plane (H//c) and in plane (H//ab), respectively. (**b**) The field dependence of the magnetization of a film measured at various temperatures with a magnetic field applied out of plane (H//c). (**d**) The field dependence of the magnetization of a 7 SL MnBi₂Te₄ film at 10 K when a magnetic field out of plane (H//c) was applied to samples with $\varphi_r = 0.09$ and $\varphi_r = 1.0$, respectively. (**e**) The temperature dependence of the magnetic fields out of plane (H//c) for 7 SL and 11 SL, respectively. (**f**) The field dependence of the magnetization of 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic fields out of plane (H//c) for 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic fields out of plane (H//c) for 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic fields out of plane (H//c) for 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic fields out of plane (H//c) for 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic field sout of plane (H//c) for 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic field sout of plane (H//c) for 7 SL and 11 SL MnBi₂Te₄ films at 10 K when a magnetic field out of plane (H//c) was applied to samples.



Figure 4. (a) The XPS spectrum of $MnBi_2Te_4$ with photon energy 58 eV. (b) The band-mapping result of a $MnBi_2Te_4$ sample measured at 80 K along direction Γ -K with photon energy 24 eV. (c) The second derivative of (b) to enhance the visibility of a Dirac cone.

4. Conclusions

We have presented the synthesis and characterization of MnBi₂Te₄ films on a nanometer scale prepared with MBE. In controlling suitable growth conditions, we demonstrated the existence of a self-regulated growth window, resulting in a single phase and the high structural quality of MnBi₂Te₄ films confirmed with XRD and Raman spectra. A layered structure of a large area, flat surface and vdW stacking was verified with an AFM and HRTEM. The 7 SL MnBi₂Te₄ film showed an antiferromagnetic characteristic with a Néel temperature of 22 K accompanying a low-field anomalous magnetic hysteresis loop along the *c*-axis. The ARPES also confirmed the existence of a Dirac surface state and revealed that the paramagnetic state of MnBi₂Te₄ remains a TI. It is worth pointing out that the presence of the MnTe and Bi₂Te₃ impurity phases will greatly reduce or destroy the topological and magnetic properties of MnBi₂Te₄. Understanding the synthesis of antiferromagnetic topological insulators in this series with the MBE method opens a huge direction for engineering magnetism and topological states. For example, a MnBi₂Te₄ film could be integrated into a heterostructure to enable a functional adjustment. Hence, antiferromagnetic TI/ferromagnetic material heterostructures with exotic quantum phases could be realized [29]. In addition, the antiferromagnetic TI/superconductor heterostructures could provide a platform to explore tunable Majorana bound states [53]. Our work paves the way for future device applications involving antiferromagnetic topological insulators.

Supplementary Materials: The following are available online at https://www.mdpi.com/article/10 .3390/nano11123322/s1, Figure S1: TEM-EDX spectrum of MnBi₂Te₄ film. Table S1: Atomic ratio of Bi, Mn and Te of the sample. **Author Contributions:** M.-C.T. and Y.-W.P. undertook the MBE growth of the samples and the XRD, SQUID, TEM and Raman experiments. S.-H.S. and J.-T.C. performed the STM experiments. P.-Y.C. and C.-M.C. conducted the ARPES experiments. M.K.L. assisted with the SQUID experiments. S.-H.S., C.-M.C. and J.-C.A.H. wrote and revised the manuscript with input from all authors. All authors discussed the results. All authors have read and agreed to the published version of the manuscript.

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Data Availability Statement: All data included in this study are available upon request by contact with the corresponding author.

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